



IFW

Docket No.: 071971-0251

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 53080
	:	
Makoto KITABATAKE, et al.	:	Confirmation Number: 6640
	:	
Application No.: 10/536,828	:	Group Art Unit: 2814
	:	
Filed: May 27, 2005	:	Examiner: Abul KALAM
	:	

For: SEMICONDUCTOR APPARATUS INCLUDING POWER SEMICONDUCTOR DEVICE
CONSTRUCTED BY USING WIDE BAN GAP SEMICONDUCTOR

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits. No certification or fee is required.

The references were cited in a corresponding Chinese Office Action and their relevance discussed therein. A copy of the Chinese Office Action, together with an English language version thereof, is attached for the Examiner's information.

10/536,828

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP



Michael E. Fogarty
Registration No. 36,139

600 13th Street, N.W.
Washington, DC 20005-3096
Phone: 202.756.8000 MEF:aej
Facsimile: 202.756.8087
Date: October 26, 2007

**Please recognize our Customer No. 53080
as our correspondence address.**